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APPLICANTS

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**** CONTINUING DATA** *Yes* *IL*
This application is a 371 of PCT/JP03/00206 01/14/2003

**** FOREIGN APPLICATIONS** *Yes* *IL*
JAPAN 2002005827 01/15/2002

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 6	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 3
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35 USC 119 (a-d) conditions met
☒ yes ☒ no ☐ Met after Allowance

Verified and Acknowledged
Examiner's Signature: *[Signature]* Initials: *IL*

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TITLE
Cvd method and device for forming silicon-containing insulation film

FILING FEE RECEIVED 920	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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